

L Number	Hits	Search Text	DB	Time stamp
9	0	(semiconductor near fiber) and (ball near2 lens) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 11:19
16	2	(semiconductor near fiber) and (ball near2 lens) and ((fabry near perot) or fp) and (DFB or (distributed near feed near back))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 11:20
-	1	(semiconductor near laser) and shaper and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 07:22
-	1	(semiconductor near laser) and shaper and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:20
-	85	(semiconductor near laser) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:02
-	13	((semiconductor near laser) and (oxidi\$4 near aluminium) ) and optical near fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:02
-	25	((semiconductor near laser) and (oxidi\$4 near aluminium) ) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:43
-	23	(semiconductor near laser) and shape and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:22
-	10	((semiconductor near laser) and shape and (oxidi\$4 near aluminium) ) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:23
-	2	(semiconductor near laser) and (beam near shape) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:22
-	12	((semiconductor near laser) and (oxidi\$4 near aluminium) ) and fiber) and lens	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:35

-	286	(semiconductor near laser) and (mirror near (concave or convex)) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:45
-	22	(semiconductor near laser) and (mirror near aluminium) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:49
-	7	((semiconductor near laser) and (mirror near aluminium) and fiber) and ((semiconductor near laser) and (mirror near (concave or convex)) and fiber)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:46
-	0	(semiconductor near laser) and (lens near aluminium) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:49
-	1	(semiconductor near laser) and (lens near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:51
-	62	(semiconductor near laser) and (shap\$3 near2 aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:07
-	25	(semiconductor near laser) and (shap\$3 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:58
-	26	(semiconductor near laser) and ((shap\$3 or lens) near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:59
-	72	(semiconductor near laser) and ((shap\$3 or lens) near2 aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:12
-	485	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:13
-	112	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium) and (trench or groove)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:14
-	34	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium) and (trench or groove) AND FIBER	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:44

-	1864	(semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:46
-	660	((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND 372/\$	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:46
-	594	((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND aluminium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:29
-	43	((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND aluminium) and ((fabry near perot) or fp) and (DFB or (distributed near feed near back))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 11:24
-	79	((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND aluminium near oxid\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:30
-	6	((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND aluminium near oxid\$4) and (((semiconductor near laser) and (shap\$3 or lens) and (trench or groove) AND FIBER) AND aluminium) and ((fabry near perot) or fp) and (DFB or (distributed near feed near back)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:30
-	193	(semiconductor near laser) and (ball near2 lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29
-	1113	(semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:18
-	0	(semiconductor near laser) and ((convex or concave) near beam near shaper)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:19
-	20	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:28
-	1	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/92	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29

-	0	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/99	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:28
-	0	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29
-	16	(semiconductor near fiber) and (ball near2 lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 10:42